

**Search Notes**

Application/Control No.

10/814,901

Examiner

John Rivell

Applicant(s)/Patent under  
Reexamination

KAYUKAWA, HISASHI

Art Unit

3753

**SEARCHED**

Class	Subclass	Date	Examiner
137	223 234.5 454.5 541	7/17/2006	
152	415 427 429	7/17/2006	
152	Dig. 11	7/17/2006	

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
None	7/18/2006	